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[57] ABSTRACT

In an organic electroluminescent device including first and second electrodes opposite to each other and a multi-layered body which is sandwiched between these electrodes and consists of a plurality of organic films including a light-emitting layer, a material for each organic film and electrode is selected so that electrons and holes are simultaneously and respectively injected from the first and second electrodes in the multi-layered body when a forward biasing voltage is applied, a large amount of injected electrons and holes are accumulated at the multi-layered body, and these electrons and holes are subjected to radiative recombination at a predetermined threshold voltage.

7 Claims, 20 Drawing Sheets

[54]	ORGANIC DEVICE	ELECTROLUMINESCENT
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